

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/990,001	HACHIMURA, FUTOSHI	
Examiner	Art Unit	
Longbit Chai	2131	

SEARCHED					
Class	Subclass	Date	Examiner		
	(n	one)			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
726/2-7; 27-30; 7(3/151-(59;182-186 (89-194	175/65	The		
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